Gradient-based Sharpness Function

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Abstract—Most autofocus methods are based on a sharpness function which delivers a real-valued estimate of an image quality. In this paper we study an L_2 -norm gradient-based sharpness function for two-dimensional images (2-D setting). Within this setting we are able to take into account the asymmetry of the optical device objective lens (astigmatism aberration). This study provides a useful extension of the analytical observations for one-dimensional images (1-D setting) that have been done before. The gradient-based autofocus method is implemented and demonstrated for the real-world application running in the FEI scanning transmission electron microscope prototype.

Index Terms—Defocus, autofocus, astigmatism, sharpness function, gradient

I. INTRODUCTION

N image obtained with an optical device, such as a A photocamera, a telescope or a microscope, depends on a given object's geometry, known as the object function, and the optical device control variables (for instance, defocus). The method of automatic defocus determination, such that the recorded image is *in-focus*, is known as *autofocus* method. In this paper we use the low resolution scanning transmission electron microscopy (STEM) as a reference application for our method. The magnetic lenses in the electron microscope usually suffer from astigmatism aberration (the objective lens is not rotationally symmetric). Astigmatism is controlled by two stigmator control variables. The method of automatic determination of stigmator values is known as automated astigmatism correction. Nowadays STEM still requires an expert operator to trigger recording of in-focus and astigmatism-free images using a visual feedback [1].

The existing autofocus methods used for different types of optical devices are usually based on a *sharpness function*, a real-valued estimate of the image's sharpness. For a through-focus series an ideal sharpness function should reach a single optimum at the in-focus image. Existing sharpness functions are based on the image derivatives [2], variance [3], [4], autocorrelation [5], histogram [6] or Fourier transform [7]. An overview of these functions can be found in [8], [9]. A sharpness function can be also used for simultaneous defocus and astigmatism correction if it is optimized in the three-parameter space [4], [10]. Also the sharpness functions are used for the study of hysteresis in electromagnetic lenses [11].

In this paper we study a gradient-based sharpness function. The advantage of using this function is demonstrated experimentally for different optical devices [6], [8], [9], [12].

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It has been shown analytically for the 1-D setting that for the noise-free image formation the L_2 -norm derivativebased sharpness function reaches its unique optimum for the in-focus image. Moreover under certain assumptions the function can accurately be approximated by a quadratic polynomial [13]. In this paper the study is extended to the 2-D setting. Only within this setting we can take into account the influence of the astigmatism on the sharpness function. The method is implemented in a FEI STEM and is demonstrated for a real-world microscopy application.

The paper is set up as follows: Section II explains the image formation modelling. Section III formulates the process of automated correction. The theoretical observations on the gradient-based sharpness function are given. Section IV presents the results of the on-line autofocus correction method implemented and running on a FEI STEM prototype.

II. MODELLING

In Subsection II-A of this section we describe notation and conventions used in this paper. The work principle of defocus and stigmator control variables is explained in Subsection II-B. Subsequently, Subsection II-C provides the model for the point spread function and relates its characteristics to the control variables. Finally, the models for the image formation and the object geometry are explained in subsections II-D, II-E respectively.

A. Notation and conventions

The 2-D spatial and frequency coordinates are denoted as $\mathbf{x} := (x, y)^T$, $\mathbf{u} := (u, v)^T \in \mathbb{R}^2$ respectively. For a vector $\mathbf{w} := (w_i)_{i=1}^N$ we define $\mathbf{w}^p := (|w_i|^p)_{i=1}^N$, $|\mathbf{w}| := (\sum_i |w_i|^2)^{1/2}$. The L_2 -norm of a function is defined as

$$\|f\|_{L_2} := \left(\iint_{-\infty}^{\infty} |f|^2 \mathrm{d}\mathbf{x}\right)^{1/2},$$

and $\mathbb{L}_2(\mathbb{R}^2)$ is the space of functions with finite L_2 -norm. The Fourier transform \hat{f} of a function $f \in \mathbb{L}_2(\mathbb{R}^2)$ plays a fundamental role in our analysis and modeling

$$\mathfrak{F}[f(\mathbf{x})](\mathbf{u}) := \widehat{f}(\mathbf{u}) := \iint_{-\infty}^{\infty} f(\mathbf{x}) e^{-i\mathbf{u}\cdot\mathbf{x}} d\mathbf{x},$$

where \cdot denotes the vector inner product. The rotation operator $R_{\theta} : \mathbb{L}_2(\mathbb{R}^2) \to \mathbb{L}_2(\mathbb{R}^2)$ is defined by $R_{\theta}f(\mathbf{x}) := f(\mathbf{R}_{\theta}\mathbf{x})$ where \mathbf{R}_{θ} is the rotation matrix

$$\mathbf{R}_{\theta} := \begin{pmatrix} \cos\theta & -\sin\theta \\ \sin\theta & \cos\theta \end{pmatrix}, \tag{1}$$

and the stretching matrix is defined as follows

$$\mathbf{Q}_{\zeta} := \begin{pmatrix} \zeta & 0\\ 0 & 1/\zeta \end{pmatrix}.$$
 (2)



Fig. 1. 1(a) Ray diagram for astigmatism-free situation; 1(b) ray diagram for a lens with astigmatism, the lens has two focal points.

B. Optical device control variables

Figure 1(a) shows the ray diagram, where the objective lens has one focal point F. The only adjustable parameter is the current through the magnetic lens; it changes the lens focal length and focuses the magnetic beam on the image plane [14]. The current is adjusted with the *defocus* control variable *d*. Astigmatism implies that the rays traveling through a horizontal plane and the rays traveling through a vertical plane will meet in different focal points (F_1 and F_2 in Figure 1(b)). Thus, the image cannot be totally sharp.

For astigmatism correction in electron microscopy, electrostatic or electromagnetic *stigmators* are used (Figure 2(a)). They produce the electromagnetic field for the correction of the ellipticity of the electron beam [15]. Currents of the same magnitude go through coils A_k , while currents of a different magnitude go through coils B_k (k = 1, ..., 4). The field generated by A_k influences the stretching of the electron beam along two orthogonal axes A_l (l = 1, 2). Similarly, the field generated by B_k influences the stretching along axes B_l , see also [14]. The angle between A_1 and B_1 is always $\frac{\pi}{4}$. The magnitude and direction of the current through coils A_k are controlled by the stigmator control variable d_x , through B_k - control variable d_y .

We will deal with the vector of three control variables

$$\mathbf{d} := (d, d_{\mathbf{x}}, d_{\mathbf{y}})^T.$$
(3)

The vector of the ideal control variables values (the setting when the output image has the highest possible quality) is defined as

$$\mathbf{d}_0 := (d_0, d_{\mathbf{x}_0}, d_{\mathbf{y}_0})^T.$$
(4)

Let $\rho \in \mathbb{L}_2(\mathbb{R}^2)$ be the *point spread function (PSF)*, the function that describes the shape of electron beam. By adjusting the machine controls we obtain

$$\breve{\varrho} = C \varrho(\mathbf{T}_{\mathbf{d}} \mathbf{x}), \tag{5}$$

$$\mathbf{T}_{\mathbf{d}} := \frac{1}{d - d_0} \mathbf{Q}_{d_{\mathbf{x}} - d_{\mathbf{x}_0} + 1} \mathbf{R}_{\pi/4} \mathbf{Q}_{d_{\mathbf{y}} - d_{\mathbf{y}_0} + 1} \mathbf{R}_{-\pi/4}.$$

In (5) *C* is the normalization constant such that after the transformation the PSF still satisfies $\int_{-\infty}^{\infty} \check{\varrho}(\mathbf{x}) d\mathbf{x} = 1$. In (5) defocus *d* is proportional to the PSF width, $\mathbf{Q}_{d_x-d_{x_0}+1}$ controls the stretching in the horizontal and vertical directions, $\mathbf{R}_{\pi/4}\mathbf{Q}_{d_y-d_{y_0}+1}\mathbf{R}_{-\pi/4}$ controls the stretching in the diagonal directions.

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C. Point spread function

The PSF can accurately be approximated by a *Lévi stable density* function for a wide class of optical devices [16], [17]. The Lévi stable density function is implicitly defined via its Fourier transform in 1-D as follows

$$\hat{\varrho}_{\sigma}(\omega) := e^{-\sigma^2 \omega^{2\beta}/2}, \quad 0 < \beta \le 1.$$
(6)

The parameter β in (6) depends on the optical device. If $\beta = 1$ in (6), the PSF is a Gaussian function. The parameter σ in (8) is known as the *width* of the PSF. In 1-D setting it is simply related to the defocus control variable d

$$\sigma = d - d_0,$$

where d_0 is unknown. In real-world applications $d \neq d_0$ due to the physical limitations of the objective lens, thus the PSF width is never equal to zero.

Due to the presence of astigmatism the PSF in 2-D setting is not always rotationally symmetric. To find a 2-D PSF we consider a tensor product of 1-D functions in x and y directions taking into account the possibility of system rotation with the angle θ

$$\hat{\varrho}_{\sigma}(\mathbf{u}) := e^{-\frac{1}{2}|(\mathbf{R}_{\theta}\mathbf{J}_{\sigma}\mathbf{u})^{\beta}|^{2}},\tag{7}$$

$$\boldsymbol{\sigma} := (\sigma - \varsigma, \sigma + \varsigma)^T, \quad \mathbf{J}_{\boldsymbol{\sigma}} := \begin{pmatrix} \sigma - \varsigma & 0\\ 0 & \sigma + \varsigma \end{pmatrix}.$$
(8)

For the Fourier transform it trivially follows that

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$$\mathfrak{F}[\varrho(\mathbf{R}\mathbf{x})](\mathbf{u}) := \iint_{-\infty}^{\infty} \varrho(\mathbf{R}\mathbf{x}) e^{-i\mathbf{u}\cdot\mathbf{x}} d\mathbf{x} \underset{\mathbf{y}=\mathbf{R}\mathbf{x}}{=}$$
$$\frac{1}{\det \mathbf{R}|} \iint_{-\infty}^{\infty} \varrho(\mathbf{y}) e^{-i(\mathbf{R}^{-T}\mathbf{u})\cdot\mathbf{y}} d\mathbf{y} = \frac{1}{|\det \mathbf{R}|} \hat{\varrho}(\mathbf{R}^{-T}\mathbf{u}).$$

Therefore the rotation angle θ of the PSF in Fourier space is equal to the rotation angle of the PSF in the real space

$$\mathfrak{F}[R_{\theta}\varrho] = R_{\theta}\hat{\varrho}.$$

Figure 2(b) shows a schematic representation of such an elliptic PSF. If $\varsigma = 0$ in (8) the astigmatism is not present, and the PSF is rotationally symmetric. If astigmatism is present ($\varsigma \neq 0$), and at the same time $\sigma = 0$ (i.e. the image is in-focus), the PSF is symmetric with the width ς , which means that the image is not totally sharp.

For the suggested model we can easily find the relation between PSF parameters and control variables

$$\sigma = \frac{d - d_0}{\sqrt{2(d_y - d_{y_0} + 1)^2 + \frac{2}{(d_y - d_{y_0} + 1)^2}}} \times \left(\frac{d_x - d_{x_0} + 1 + \frac{1}{d_x - d_{x_0} + 1}}{\sqrt{2(d_y - d_{y_0} + 1)^2 + \frac{2}{(d_y - d_{y_0} + 1)^2}}} \times \left(\frac{d - d_0}{\sqrt{2(d_y - d_{y_0} + 1)^2 + \frac{2}{(d_y - d_{y_0} + 1)^2}}}{\left(\frac{d_x - d_{x_0} + 1 - \frac{1}{d_x - d_{x_0} + 1}}{\sqrt{2(d_y - d_{y_0} + 1)^2 + 1}} \right),$$

$$\theta = \arccos \frac{(d_y - d_{y_0} + 1)^2 + 1}{\sqrt{2(d_y - d_{y_0} + 1)^2 + 2}}.$$



Fig. 2. 2(a): typical configuration of electrostatic stigmators [14]; 2(b): asymmetric PSF in Fourier space, schematic representation; 2(c): The image formation model; 2(d): Sharpness function S reaches its optimum at the in-focus image. The goal of the autofocus procedure is to find the value of defocus d_0 .

D. Linear image formation model

Images for which our sharpness function will be computed are the output images $f \in \mathbb{L}_2(\mathbb{R}^2)$ of the so-called *image* formation model represented by Figure 2(c). The object's geometry (or the *object function*) is denoted by ψ . The filter ϱ_{σ} describes the PSF of an optical device.

The output of the ρ_{σ} filter is denoted by f_0 and is often post-processed by a PC. We assume that in such postprocessing a Gaussian filter $g_{\alpha}(\mathbf{x}) := \frac{1}{2\pi\alpha^2} e^{-\frac{|\mathbf{x}|^2}{2\alpha^2}}$ is applied to the image f_0 . Filtering with a Gaussian kernel is often used for denoising purposes, which is an easy alternative to more advanced techniques [18], [19], [20]. It has been shown that the control variable α is useful not only for denoising the image f_0 ; it also influences the approximation error when the sharpness function is replaced by a quadratic polynomial [13]. The value of α is fixed during the autofocus process.

We apply the *linear image formation model*, which is often used for different optical devices [2], in particular for electron microscopes [3]. In this paper we consider low-to-medium magnification of the electron microscope (resolution higher or equal to 1 nm), thus the image formation can be approximated with this model [21]. This implies that the occurring filters are linear and space invariant which can easily be described by means of *convolution* products

$$f_0 := \psi * \varrho_\sigma, \quad f := f_0 * g_\alpha. \tag{9}$$

If no post-processing is applied, $\alpha = 0$, and $f = f_0$.

E. Object function

We assume that the object function satisfies

$$\iint_{-\infty}^{\infty} |\psi(\mathbf{x})| d\mathbf{x} < \infty.$$
 (10)

In practice this will easily be satisfied because the function ψ has a finite domain, i.e., the image has a finite size. As a consequence $\hat{\psi}$ is bounded and continuous.

In classical signal analysis a discrete signal ψ is modelled as a finite linear combination of delta functions

$$\psi(\mathbf{x}) = \sum_{k,l=1}^{K} a_{k,l} \delta(\mathbf{x} - \tau \mathbf{k}), \quad \mathbf{k} := (k,l)^{T}, \quad \tau > 0.$$
(11)

We consider the image with a finite number of *pixels* $a_{k,l}$, i.e. $K < \infty$. In this case $\hat{\psi}$ is a tri-geometric polynomial which again is bounded and smooth.

Property 1. *The power spectrum of the object function (11) can be expressed as*

$$|\hat{\psi}(\mathbf{u})|^2 = \sum_{n,m} \rho_{n,m} e^{i\tau \mathbf{n} \cdot \mathbf{u}}, \quad \mathbf{n} := (n,m)^T, \quad (12)$$

where

$$\rho_{n,m} := \sum_{k,l} a_{k,l} a_{n+k,m+l},\tag{13}$$

are the autocorrelation coëfficiënts of the pixel values.

Proof: The proof is analogue to the 1-D case [13]. As a special example of an object function consider

$$|\hat{\psi}(\mathbf{u})|^2 = Ce^{-|\mathbf{u}|^2\gamma^2}, \quad C > 0, \quad \gamma \ge 0.$$
 (14)

Such images, for $\gamma > 0$, often occur in real-world applications from single particles. For $\gamma = 0$ in (14), $|\hat{\psi}|^2$ is constant, which corresponds to the situation when the object is nearly *amorphous* [3].

III. GRADIENT-BASED SHARPNESS FUNCTION

The existing autofocus methods used for different types of optical devices are usually based on a sharpness function $S : \mathbb{L}_2(\mathbb{R}^2) \to \mathbb{R}$, a real-valued estimate of the image's quality. For a through-focus series of images the sharpness function is computed for different values of d given a fixed value of α . A general behaviour of a sharpness function is shown in Figure 2(d). The image at the defocus $d = d_0$ is sharp or *in-focus* and the sharpness function reaches its optimum. The image far away from d_0 is called *out-of-focus*.

For simultaneous defocus and astigmatism correction stigmator controls are ajusted as well, and the goal is to estimate d_0 from the values of the sharpness function computed at different points.

In this section we provide the general properties of the gradient-based sharpness function

$$S := \left\| |\nabla f| \right\|_{L^2}^2. \tag{15}$$

Property 2. If f is given by (9) with the PSF (7) then the sharpness function (15) can be written as follows

$$S(\sigma) = \frac{1}{2\pi} \iint_{-\infty}^{\infty} |\mathbf{u}|^2 |\hat{\psi}(\mathbf{u})|^2 e^{-|(\mathbf{R}_{\theta} \mathbf{J}_{\sigma} \mathbf{u})^{\beta}|^2} e^{-|\mathbf{u}|^2 \alpha^2} d\mathbf{u}.$$
(16)

Proof: Because of Parseval's identity we have

$$S(\sigma) = \frac{1}{2\pi} \iint_{-\infty}^{\infty} |\mathbf{u}|^2 |\hat{\psi}(\mathbf{u})|^2 |\hat{\varrho}_{\sigma}(\mathbf{u})|^2 |\hat{g}_{\alpha}(\mathbf{u})|^2 \mathrm{d}\mathbf{u}.$$

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A. Rotationally symmetric PSF

In the corollaries, the property and the theorem below we first consider the sharpness function (15) for the rotationally symmetric PSF, ($\varsigma = 0$ in (8)).

Corollary 1. The sharpness function can be expressed as

$$S(\sigma) = \frac{1}{2\pi} \iint_{-\infty}^{\infty} |\mathbf{u}|^2 |\hat{\psi}(\mathbf{u})|^2 e^{-\sigma^{2\beta} |\mathbf{u}^{\beta}|^2} e^{-|\mathbf{u}|^2 \alpha^2} d\mathbf{u}.$$
 (17)

Corollary 2. The sharpness function is smooth, and is strictly increasing for $\sigma < 0$ and strictly decreasing for $\sigma > 0$.

Corollary 3. The sharpness function has a finite maximum at $\sigma = 0$ for $\alpha > 0$; in particular $\max_{\sigma} S(\sigma) = S(0)$.

It follows that the basic properties of the gradient-based sharpness function in 2-D are similar to the properties in 1-D [13], if we consider a rotationally symmetric PSF: for the noise free image formation the function has a unique optimum at the in-focus image. Further we consider the Gaussian PSF ($\beta = 1$ in (7)).

Property 3. The sharpness function S can be expressed by means of the autocorrelation coëfficients (13) as follows

$$S(\sigma) = \frac{1}{2\pi(\sigma^2 + \alpha^2)^2} \sum_{n,m} \rho_{n,m} \iint_{-\infty}^{\infty} |\mathbf{u}|^2 e^{\frac{i\pi n \cdot \mathbf{u}}{\sqrt{\alpha^2 + \sigma^2}}} e^{-|\mathbf{u}|^2} d\mathbf{u}$$
(18)

Proof: After we rewrite the sharpness function (17)

$$S(\sigma) = \frac{1}{2\pi(\sigma^2 + \alpha^2)^2} \iint_{-\infty}^{\infty} |\mathbf{u}|^2 |\hat{\psi}(\frac{\mathbf{u}}{\sqrt{\alpha^2 + \sigma^2}})|^2 e^{-|\mathbf{u}|^2} \mathrm{d}\mathbf{u}.$$

and substitute the expression for the power spectrum (12), we achieve (18).

Theorem 1. The sharpness function can be expressed as

$$S(\sigma) = \frac{C_1}{2\pi(\alpha^2 + \sigma^2)^2} (1 + R_1(\sigma)),$$
(19)

where

$$|R_1(\sigma)| \le K_1 \frac{\tau}{\sqrt{\alpha^2 + \sigma^2}},\tag{20}$$

and C_1, K_1 depend only on the pixel values $a_{k,l}$.

Proof: Splitting $e^{\frac{i\tau \mathbf{r} \cdot \mathbf{u}}{\sqrt{\alpha^2 + \sigma^2}}}$ into $(e^{\frac{i\tau \mathbf{r} \cdot \mathbf{u}}{\sqrt{\alpha^2 + \sigma^2}}} - 1) + 1$ in (18), one obtains

$$S(\sigma) = \frac{1}{2\pi(\sigma^2 + \alpha^2)^2} \Big(\underbrace{\iint_{-\infty}^{\infty} |\mathbf{u}|^2 e^{-|\mathbf{u}|^2} \mathrm{d}\mathbf{u} \sum_{n,m} \rho_{n,m}}_{C_1} + \underbrace{\iint_{-\infty}^{\infty} |\mathbf{u}|^2 e^{-|\mathbf{u}|^2} \sum_{n,m} \rho_{n,m} (e^{\frac{\mathrm{i}\tau \mathbf{n} \cdot \mathbf{u}}{\sqrt{\alpha^2 + \sigma^2}}} - 1) \mathrm{d}\mathbf{u} \Big).$$
(21)

It trivially follows that

$$C_1 = \iint_{-\infty}^{\infty} |\mathbf{u}|^2 e^{-|\mathbf{u}|^2} \mathrm{d}\mathbf{u} \sum_{n,m} \rho_{n,m} = \pi \sum_{n,m} \rho_{n,m}.$$

To estimate R_1 observe that

$$|e^{i\eta} - 1| = 2|\sin\frac{\eta}{2}| \le |\eta|, \quad \eta \in \mathbb{R},$$
(22)

for $\eta = \frac{\tau \mathbf{n} \cdot \mathbf{u}}{\sqrt{\alpha^2 + \sigma^2}}$, and consequently

$$\left|\sum_{n,m} \rho_{n,m} \left(e^{\frac{i\tau \mathbf{n} \cdot \mathbf{u}}{\sqrt{\alpha^2 + \sigma^2}}} - 1 \right) \right| \leq \leq \frac{\tau}{\sqrt{\alpha^2 + \sigma^2}} \left(|u| \sum_{n,m} |n| \rho_{n,m} + |v| \sum_{n,m} |m| \rho_{n,m} \right).$$
(23)

It follows

$$\left| \iint_{-\infty}^{\infty} |\mathbf{u}|^2 e^{-|\mathbf{u}|^2} \sum_{n,m} \rho_{n,m} \left(e^{\frac{\mathrm{i}\tau n \cdot \mathbf{u}}{\sqrt{\alpha^2 + \sigma^2}}} - 1 \right) \mathrm{d}\mathbf{u} \right| \leq \frac{3\sqrt{\pi}}{2} \frac{\tau}{\sqrt{\alpha^2 + \sigma^2}} \sum_{n,m} (|n| + |m|) \rho_{n,m}.$$

Then the statement of the theorem is straightforward with

$$K_1 = \frac{3}{2\sqrt{\pi}} \frac{\sum_{n,m} (|n| + |m|)\rho_{n,m}}{\sum_{n,m} \rho_{n,m}}.$$

It follows from (19) that the function $S^{-1/2}(\sigma)$ can be approximated with any accuracy by a quadratic polynomial by increasing the value of the control variable α . This also corresponds to the findings made for the 1-D setting before. The only difference is the power of the sharpness function to be taken for a quadratic approximation. Below we examine a more general case of a non-symmetric PSF.

B. Non-symmetric PSF

Property 4. *Image rotation does not influence the sharpness function, i.e.*

$$S[R_{\theta}f] = S[f].$$

Proof: Rotation transformation is just a linear transformation of the coordinates, which satisfies the properties det $\mathbf{R}_{\theta} = 1$, $\mathbf{R}_{\theta}^{-T} = \mathbf{R}_{\theta}$, thus

$$S[R_{\theta}f] = \|\frac{\partial}{\partial x}R_{\theta}f\|_{L_{2}} = \|R_{\theta}\frac{\partial}{\partial x}f\|_{L_{2}} = \frac{1}{\det R_{\theta}}\|\frac{\partial}{\partial x}f\|_{L_{2}}.$$

Corollary 4. For the linear image formation model, the rotation of the PSF does not influence the sharpness function

$$S[\psi * R_{\theta} \varrho_{\sigma} * g_{\alpha}] = S[\psi * \varrho_{\sigma} * g_{\alpha}].$$

For further simplification of our analysis we make therefore a general assumption $\theta = 0$ in (16). In these case the adjustment of stigmator d_y is not necessary. Neglecting the PSF rotation angle does not limit the theoretical observations. However, in real-world applications defocus and astigmatism correction still remain a three-parameter problem. It has not been possible so far to implement PSF rotation directly in the hardware; thus its elliptic form can be adjusted only by a combination of the two stigmator control variables.

Property 5. For the object function (14) and the Gaussian *PSF* the sharpness function (15) is given by

$$S(\sigma) = \frac{C(\varsigma^2 + \sigma^2 + \alpha^2 + \gamma^2)}{2\left((\varsigma^2 + \sigma^2 + \alpha^2 + \gamma^2)^2 - 4\varsigma^2\sigma^2\right)^{3/2}}.$$
 (24)

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Fig. 3. Sharpness functions S shapes.

Proof: By definition

$$\begin{split} \|\frac{\partial}{\partial x}f\|_{L_{2}}^{2} &= \frac{1}{2\pi} \int_{-\infty}^{\infty} u^{2}e^{-((\varsigma-\sigma)^{2}+\alpha^{2}+\gamma^{2})u^{2}} \mathrm{d}u \times \\ &\int_{-\infty}^{\infty} e^{-((\varsigma+\sigma)^{2}+\alpha^{2}+\gamma^{2})v^{2}} \mathrm{d}v = \\ \frac{C}{4}((\varsigma-\sigma)^{2}+\alpha^{2}+\gamma^{2})^{-3/2}((\varsigma+\sigma)^{2}+\alpha^{2}+\gamma^{2})^{-1/2} \end{split}$$

Similarly we compute $\|\frac{\partial}{\partial y}f\|_{L_2}^2$, then the statement of the property is straightforward.

By analysing the derivative of the sharpness function (24)

$$S'(\sigma) = \frac{2C\sigma\Big((\alpha^2 + \gamma^2 - \sigma^2) + \varsigma^2(2\varsigma^2 + \sigma^2 - \alpha^2 - \gamma^2)\Big)}{\Big((\varsigma^2 + \sigma^2 + \alpha^2 + \gamma^2)^2 - 4\varsigma^2\sigma^2\Big)^{3/2}}$$

we find that for $\sqrt{\alpha^2 + \gamma^2} < \sqrt{2}\varsigma$ the sharpness function has three optima: a minimum at $\sigma_0 = 0$ and a maximum at σ_1 and σ_2 , where

$$\sigma_{1,2} = \pm \frac{1}{\sqrt{2}} \sqrt{\varsigma \sqrt{8\alpha^2 + 8\gamma^2 + 9\varsigma^2} - 2\alpha^2 - 2\gamma^2 - \varsigma^2}.$$
(25)

Figure 3 shows functions (24) computed for $\alpha = 0, \gamma = 0$ for different values of ς . For $\varsigma = 0$ the function has a unique optimum at $\sigma = 0$. For $\varsigma > 0$ the function has a minimum instead of maximum at the in-focus position and two local maxima at $\sigma_{1,2}$. This benchmark example is important, because it shows that due to the presence of astigmatism a standard autofocus procedure might fail. For a larger value the distance between the optima decreases, and their amplitudes are smaller (Figure 4). If $\sqrt{\alpha^2 + \gamma^2} \ge \sqrt{2}\varsigma$ the sharpness function has a maximum at $\sigma = 0$ and does not have any other optima.

The sharpness function improvement with the help of α adjustments has been shown before experimentally for an electron microscopy through-focus series with local optima due to the astigmatism presence ([13], page 13, Figure 7). The benchmark case, which we studied in this subsection gives a theoretical insight into this effect.

Property 6. For the object function (14) and the Gaussian PSF the sharpness function in the two-parameter space $S = S(\sigma)$ has a maximum at $\sigma = (0, 0)^T$ and does not have any other optimum.

Proof: It is easy to find that partial derivatives of the function (24)

$$\frac{\partial}{\partial \sigma} S(0,0) = \frac{\partial}{\partial \varsigma} S(0,0) = 0.$$

Further it is clear that for $\varsigma \in \mathbb{R}$, $\frac{\partial}{\partial \varsigma}S(\sigma_k, \varsigma) \neq 0$, k = 1, 2.

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Fig. 4. Sharpness functions S shape in a two-parameter space.

Figure 4 shows the sharpness function shape in a twoparameter space computed for $\alpha = 0.1$ and $\alpha = 2$. In both cases the sharpness function has a maximum as $\boldsymbol{\sigma} = (0,0)^T$ and does not have any other optima. This is convenient for simultaneous defocus and astigmatism correction, which could be done by optimizing the sharpness function in twoparameter space [4], [10]: the local optima that the sharpness function obtains in 1-D are not optima anymore in higher dimensions. This funding coincide with the results of the sharpness function behaviour obtained via simulations of the variance-based sharpness function [4]. Still, tuning the artificial blur α make the shaper of the sharpness function closer to convex, which might increase the speed of optimization.

Corollary below directly follows from Property 2.

Corollary 5. For the Gaussian object function and the symmetric Gaussian PSF ($\varsigma = 0$) the sharpness function (15) is given by

$$S(\sigma) = \frac{C}{2(\sigma^2 + \alpha^2 + \gamma^2)^2}.$$
(26)

In this case the sharpness function to the power -1/2 is a quadratic polynomial

$$S^{-1/2}(d-d_0) = \sqrt[2]{\frac{\pi}{C}}((d-d_0)^2 + \alpha^2 + \gamma^2).$$

is a quadratic polynomial, which is coincides with the observations of Theorem 1, which are made for a more general case.

IV. AN AUTOMATIC AUTOFOCUS ALGORITHM FOR A REAL-WORLD APPLICATION

A detailed description of the gradient-based fast autofocus method can be found in [13]. Here we just provide a short overview of the **autofocus algorithm**:

- 1) Let d_2 be the current defocus control value. Choose Δd , then $d_1 := d_2 \Delta d$, $d_3 := d_3 \Delta d$.
- 2) Obtain three images at d_1, d_2, d_3 and compute S_1, S_2, S_3 . We set N = 3.
- 3) We fit N given points with a quadratic polynomial

$$\mathcal{P}(d) := c_0 + c_1 d + c_2 d^2$$

For
$$N > 3$$
 we obtain the overdetermined system

$$\underbrace{\begin{pmatrix} 1 & d_1 & d_1^2 \\ \dots & \dots & \dots \\ 1 & d_N & d_N^2 \end{pmatrix}}_{\mathbf{D}} \underbrace{\begin{pmatrix} c_0 \\ c_1 \\ c_2 \end{pmatrix}}_{\mathbf{c}} = \underbrace{\begin{pmatrix} S_1 \\ \dots \\ S_N \end{pmatrix}}_{\mathbf{s}}.$$



Fig. 5. Image improvement by a test application implemented in a prototype FEI Tecnai F20 STEM. The plot on the right shows the fitting of the three data points with a quadratic polynomial and thus obtaining of the in-focus image.

This can e.g. be solved by least squares, giving

$$\mathbf{D}^T \mathbf{D} \mathbf{c} = \mathbf{D}^T \mathbf{s},$$

compute c; estimate the sharpness function optimum

$$l_{N+1} = -\frac{c_1}{2c_2}.$$

as the optimum of the polynomial

4) If for the given tolerance $|d_N - d_{N+1}| < d_{tol}$, stop. Else, compute $S_{N+1} = S(d_{N+1})$ and go to the previous step.

More iterations (N > 3) are required only if a very accurate focusing is needed. In step three different numerical methods could be used. The choice of the method is not quite significant for small N. For a proper choice of α it can be possible to extend the algorithm to simultaneous autofocus and astigmatism correction by fitting the sharpness function with a quadratic polynomial in a higher dimension.

The autofocus method is implemented in a prototype FEI Tecnai F20 STEM. One example of an application run is shown in Figure 5. The initial position of the machine defocus is $d_1 = -3 \ \mu m$. The defocus step $\Delta d = 5 \ \mu m$ is chosen. The two intermediate images with $d_2 = -8 \ \mu m$ and $d_3 = 2 \ \mu m$ are obtained. For each of the images $S^{-1/2}$ is computed. The position of the in-focus image is calculated from the given three images and corresponds to $d_4 = 0.3 \ \mu m$, which is within the tolerable defocus error for the given machine settings. The improvements of the image quality are visible in Figure 5. Different examples of our algorithm work for a particle analysis application can be found in [13].

V. DISCUSSION AND CONCLUSIONS

In this paper we have given a better insight into the analytical properties of the gradient-based sharpness function in the 2-D setting. It has been shown that the role of the artificial blur control variable α in the higher dimension becomes more important due to the possible presence of astigmatism. If we only do the autofocus the proper choice of α helps to avoid the multiple optima of the sharpness function. If we perform automated simultaneous defocus and astigmatism correction, by controlling α we can improve the shapes of the sharpness function and increase the speed of optimization. Our results are implemented for real-world applications and deliver a satisfactory performance.

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REFERENCES

- A. Tejada, S. van der Hoeven, A. den Dekker, and P. Van den Hof, "Towards automatic control of scanning transmission electron microscopes," in *Proc. 18th IEEE International Conference on Control Applications*, 2009, pp. 788–793.
- [2] S. K. Nayar and Y. Nakagawa, "Shape from focus," *IEEE Trans. Pattern Anal. Mach. Intell.*, vol. 16, no. 8, pp. 824–831, 1994.
 [3] S. Erasmus and K. Smith, "An automatic focusing and astigmatism
- [3] S. Erasmus and K. Smith, "An automatic focusing and astigmatism correction system for the SEM and CTEM," J. Microsc., vol. 127, no. 2, pp. 185–199, 1982.
- [4] M. Rudnaya, W. Van den Broek, R. Doornbos, R. Mattheij, and J. Maubach, "Autofocus and twofold astigmatism correction in HAADF-STEM," *Ultramicroscopy*, vol. accepted, doi:10.1016/j.ultramic.2011.01.034, 2011.
- [5] D. Vollath, "Automatic focusing by correlative methods," J. Microsc., vol. 147, pp. 279–288, Sep 1987.
- [6] E. Krotkov, "Focusing," Int. J. Comput. Vis., vol. 1, pp. 223-237, 1987.
- [7] S. Jutamulia, T. Asakura, R. Bahuguna, and C. De Guzman, "Autofocusing based on power-spectra analysis," *Applied optics*, vol. 33, no. 26, pp. 6210–6212, 1994.
- [8] T. Yeo, S. Ong, Jayasooriah, and R. Sinniah, "Autofocusing for tissue microscopy," *Image Vis. Comput.*, vol. 11, no. 10, pp. 629–639, 1993.
- [9] M. Rudnaya, R. Mattheij, and J. Maubach, "Evaluating sharpness functions for automated scanning electron microscopy," *J. Microsc.*, vol. 240, pp. 38–49, 2010.
- [10] M. Rudnaya, S. Kho, R. Mattheij, and J. Maubach, "Derivative-free optimization for autofocus and astigmatism correction in electron microscopy," in *Proc. 2nd International Conference on Engineering Optimization*, Lisbon, Portugal, 2010.
- [11] P. Van Bree, C. Van Lierop, and P. Van den Bosch, "On hysteresis in magnetic lenses of electron microscopes," in *Proc. ISIE*, Bari, Italy, 2010.
- [12] M. Rudnaya, R. Mattheij, and J. Maubach, "Iterative autofocus algorithms for scanning electron microscopy," *Microsc. Microanal.*, vol. 15(Suppl 2), pp. 1108–1109, 2009.
- [13] M. Rudnaya, H. ter Morsch, J. Maubach, and R. Mattheij, "A derivative-based fast autofocus method," Eindhoven University of Technology, CASA-report 11-13, 2011, http://www.win.tue.nl/analysis/reports/rana11-13.pdf.
- [14] K. Ong, J. Phang, and J. Thong, "A robust focusing and astigmatism correction method for the scanning electron microscope," *Scanning*, vol. 19, pp. 553–563, 1997.
- [15] W. Riecke, Topics in Current Physics: Magnetic Electron Lenses. Spring-Verlag, 1982, ch. Practical lens design, pp. 164–351.
- [16] A. Carasso, D. Bright, and A. Vladar, "APEX method and real-time blind deconvolution of scanning electron microscopy imagery," *Opt. Eng*, vol. 41, no. 10, pp. 2499–2514, 2002.
- [17] C. Johnson, "A method for characterizing electro-optical device modulation transfer function," *Photograph. Sci. Eng.*, vol. 14, no. 413–415, 1970.
- [18] S. Morigi, L. Reichel, F. Sgallari, and A. Shyshkov, "Cascadic multiresolution methods for image deblurring," *SIAM J. Imaging Sci.*, vol. 1, no. 1, pp. 51–74, 2007.
- [19] K. Kumar, M. Pisarenco, M. Rudnaya, V. Savcenco, and S. Srivastava, "Shape reconstruction techniques for optical sectioning of arbitrary objects," *Mathematics-in-Industry case studies*, vol. accepted, 2011.
- [20] T. Le, R. Chartrand, and T. Asaki, "A variational approach to reconstructing images corrupted by poisson noise," J. Math. Imaging Vis., vol. 27, no. 3, pp. 257–263, 2007.
- [21] P. Nellist and S. Pennycook, "Incoherent imaging using dynamically scattered coherent electrons," *Ultramicroscopy*, vol. 78, pp. 111–124, 1999.